



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Masashi Fujimoto

Serial No.: 09/981,912

Group Art Unit: Not Yet Assigned

Filing Date: October 19, 2001

Examiner: Unknown

For: METHOD FOR MEASURING COMA ABERRATION IN OPTICAL SYSTEM

Assistant Commissioner of Patents  
Washington, D.C. 20231

**SUBMISSION OF CORRECTED FORMAL DRAWINGS**

Sir:

Submitted herewith are corrected formal drawings for Figures 1-13(b) for the above-identified patent application.

Approval and acknowledgment of receipt are respectfully requested.

Date:

5/17/02

Respectfully submitted,

Sean M. McGinn  
Registration No. 34,386

**McGinn & Gibb, PLLC**  
Intellectual Property Law  
8321 Old Courthouse Rd. Suite 200  
Vienna, VA 22182-3817  
(703) 761-4100  
Customer No. 21254

TECHNOLOGY CENTER 2800

MAY 21 2002

RECEIVED